

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: R. TSUCHIYA et al
Serial No. 10/372,329
Filed: February 25, 2003

Group Art Unit: 2814
Examiner: N.V. Ngo
For: MIS SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF

PRELIMINARY AMENDMENT

Commissioner for Patents
Mail Stop Patent Application
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above application
as follows.